

Notice of References Cited			Application No.	Applicant(s)		
			09-788,629	Usui et. al.		
			Examiner	Group Art Unit	Page <u>1</u> of <u>1</u>	
			George Gaudreault	1763		
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*	DOCUMENT NO.	DATE	NAME		CLASS	SUBCLASS
A	5,627,640	5-9-71	Cheng et al.		356	316
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N	58-144,476	8-9-31	Japan	Watanabe et al.		
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U	"Use of a Light Emitting Diode As A Current Sensor For Electrostatic Double Probes"; Rev. of Sci. Instru.; (2-87); Vol 58, no. 2, pp. 315-317; Tendys et. al.					
W	"A Plasmroscope Using Light Emitting Diodes"; Rev. of Sci. Instru.; (1-74); Vol 45, no. 1; pp. 57-59; Ejima et. al.					
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* A copy of this reference is not being furnished with this Office action.
(See Manual of Patent Examining Procedure, Section 707.05(a).)

Part of Paper No. 4